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Optics and photonics - Microlens arrays - Part 4: Test methods for geometrical properties (ISO 14880-4:2006)

Contents		Page
Foreword		2
Endorsement notice		2
Introduction		3
1 Scope		4
2 Normative references		4
3 Terms, definitions and symbols		4
4 Coordinate system		6
5 Test methods		7
5.1 Pitch and surface modulation depth measurement		7
5.2 Physical thickness		12
5.3 Radius of curvature		12
5.4 Surface preparation of microlens array for measurement		15
6 Procedure		16
6.1 Measurement of pitch and surface modulation depth (lens sag)		16
6.2 Measurement of physical thickness		16
6.3 Measurement of radius of curvature		16
7 Results and uncertainties		16
8 Test report		17
Annex A (normative) Measurement with a Fizeau interferometer system		19
Annex B (informative) Uniformity of array spacing		22
Bibliography		25